

NNCI Computation

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Objectives

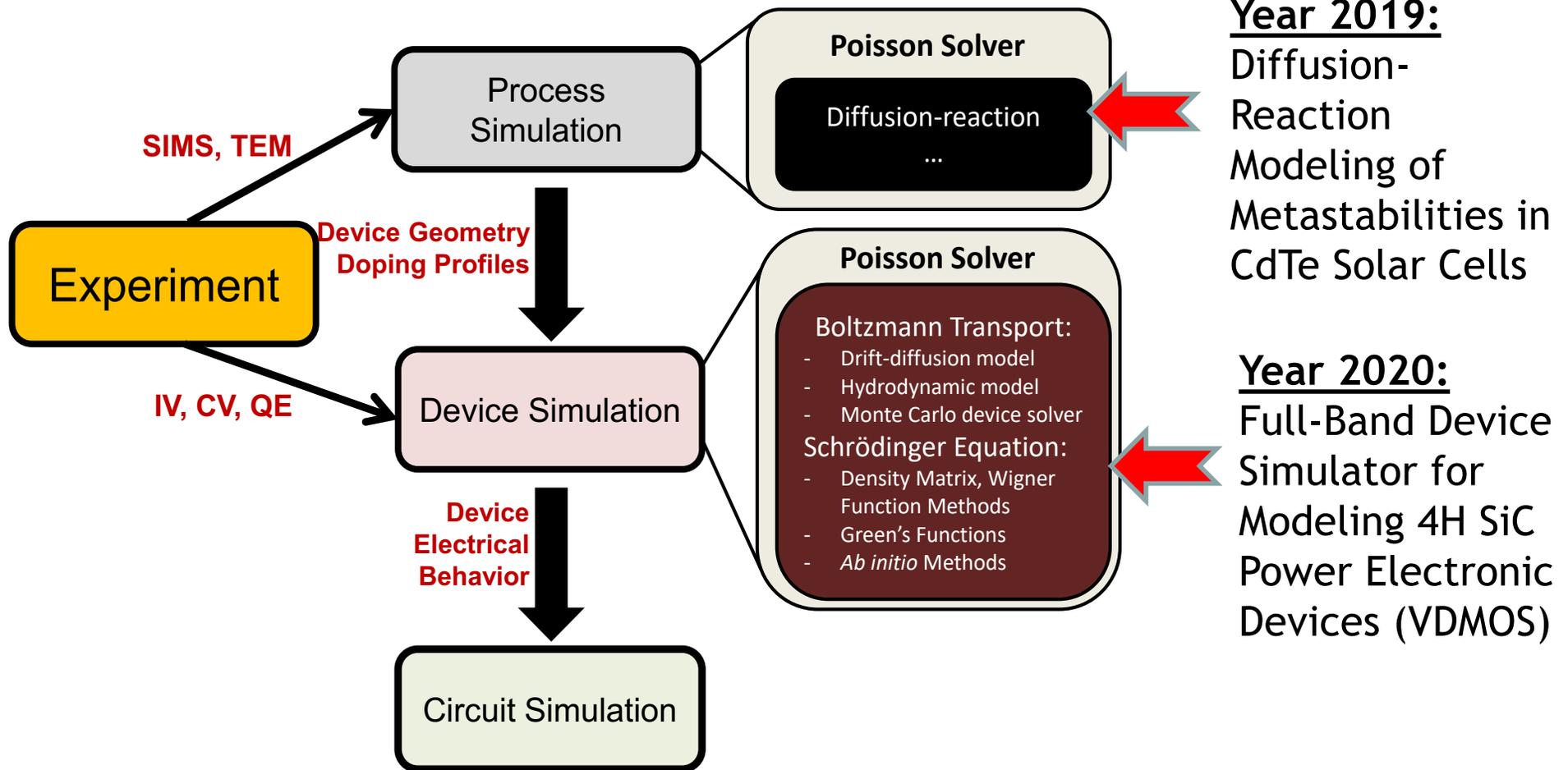
- To facilitate access to the modeling and simulation capabilities and expertise
- To identify the strategic areas for growth
- To promote and facilitate the development of the new capabilities.

An inventory of available modeling and simulation resources and expertise is being compiled. The directory is hosted by nanoHub.org.

8 supercomputers or major computing clusters are available in various sites.

<https://www.nnci.net/computation-resources>

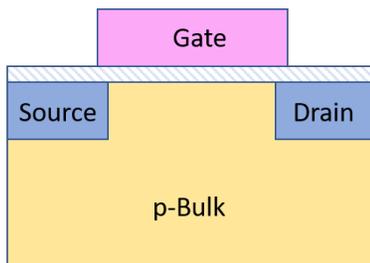
Modeling and Simulation @ NCI-SW



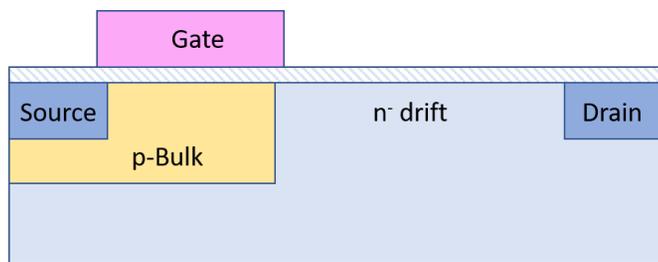
Dragica Vasileska, ASU (NCI-SW)

Device Simulation

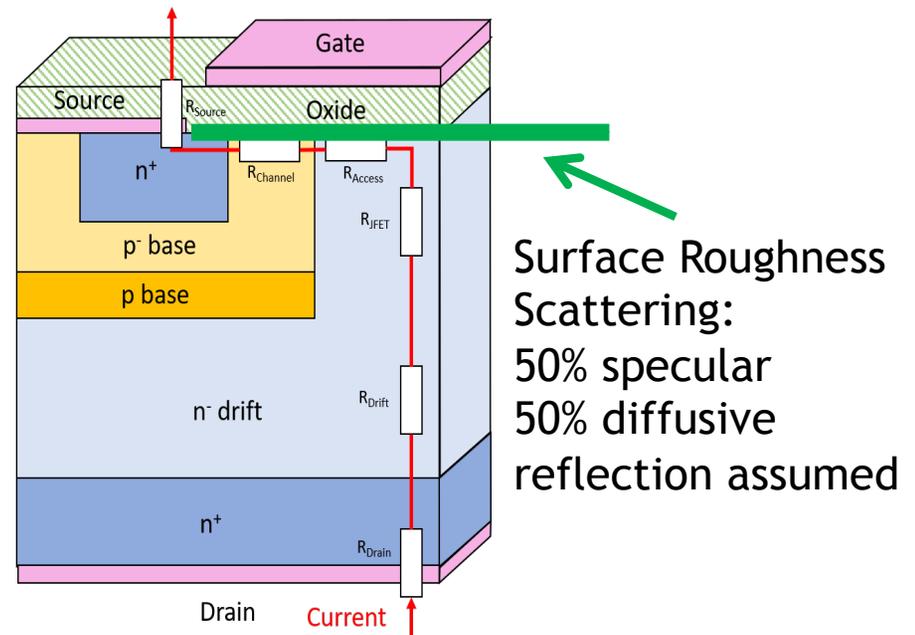
Conventional MOSFET



LDMOS: Lateral Double-Diffused MOSFET



VDMOS: Vertical Double-Diffused MOSFET



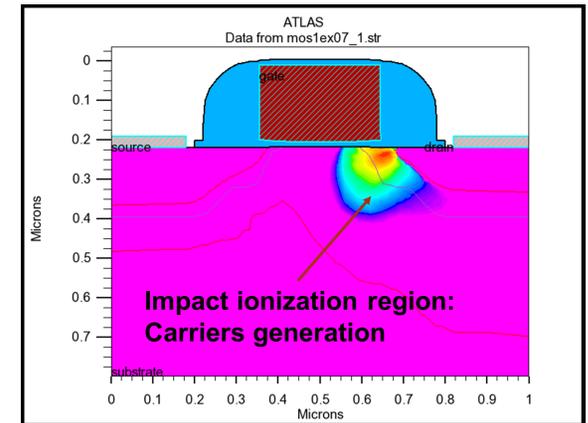
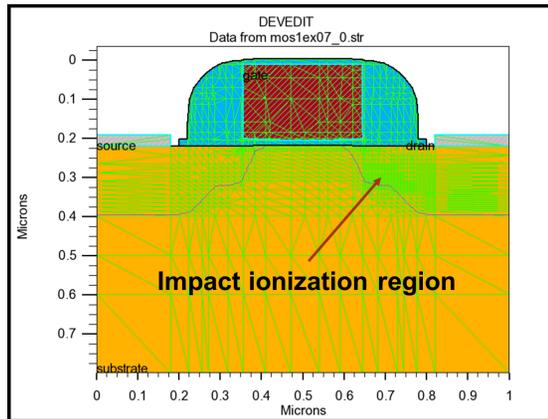
An in-house full-band Monte Carlo (FBEMC) device simulation tool is developed and validated.

Device and Process Simulation Course

Developed ONLINE Graduate Level Semiconductor Device and Process Modeling Class (primarily focused on Silvaco device/process modeling).

27 students are currently taking the class at ASU from all over United States.

- ⊙ The form of the input file statements is:
<STATEMENT> <PARAMETER> = <VALUE>
The parameter can be: real, integer, character and logical.
- ⊙ The order in which the ATLAS commands occur is the following:
 - A) Structure specification:** MESH, REGION, ELECTRODE, DOPING
 - B) Material models specification:** MATERIAL, MODELS, CONTACT, INTERFACE
 - C) Numerical method selection:** METHOD
 - D) Solution specification:** LOG, SOLVE, LOAD, SAVE
 - E) Results analysis:** EXTRACT, TONYLOT
- ⊙ The input file can be created using the DeckBuild Command Menu:
Commands/Command Menu

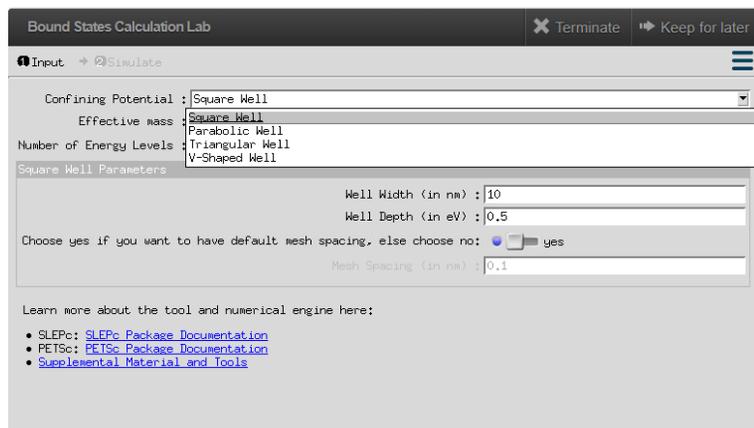


Dragica Vasileska, ASU (NCI-SW)

Contributions to nanoHUB.org

Developed Bound States Calculation Lab:

www.nanohub.org/tools/bsclab



235 users/6 months
(since April 2020)

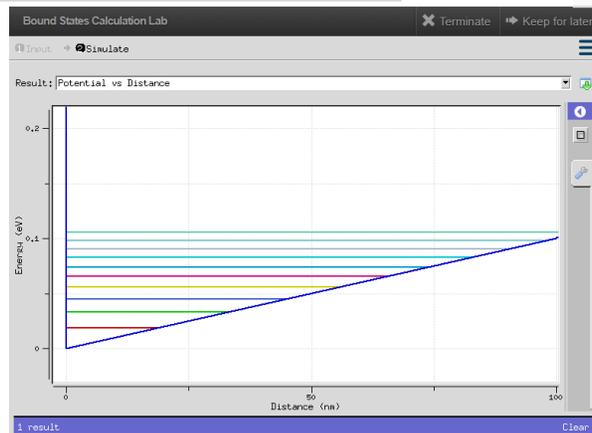
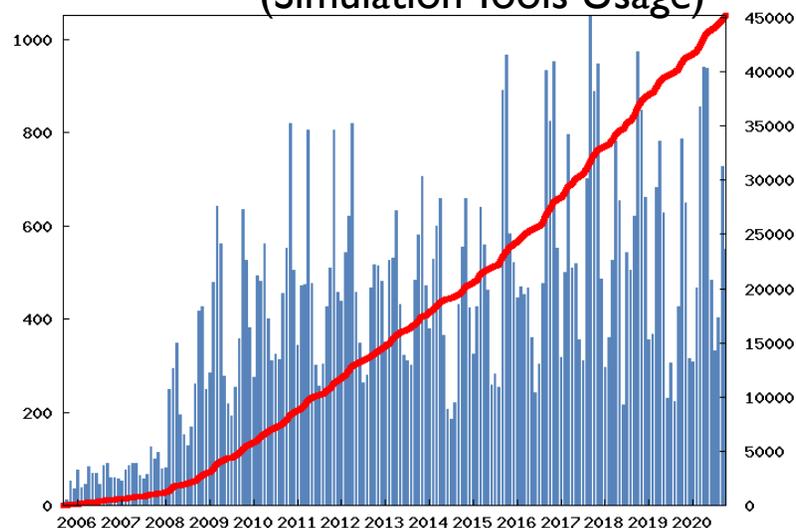


Table 1: Overview

Item	Value
Contributions:	378
Rank by Contributions:	3 / 2375
First Contribution:	09 Mar 2005
Last Contribution:	19 Mar 2020
Citations on Contributions:	181
Usage in Courses/Classrooms:	7,516 users served in 480 courses from 47 institutions

Dragica Vasileska's Impact Graph on nanoHUB.org (Simulation Tools Usage)



CNF Computing Capabilities

Resources available remotely during COVID-19

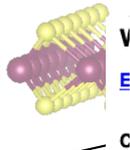
- Nanoscale simulation computing cluster
Runs Scientific Linux 7 w OpenHPC & Slurm; Bring Your Own License!
- Pseudopotential Virtual Vault
Online web database of over 1100 pseudopotential or Projected Augment Wave Method (PAW) files
- Remote access to software tools via “CNF Thin” Hotdesking service
CAD (BEAMER, L-Edit, Java GDS, AutoDesk); Simulation (Coventor, Cadence, PROLITH, Layout LAB, TRACER); Image/Data Analysis (ProSEM, NanoScope Analysis, WinFLX)
- Virtual CAD Room
Remote access to a virtual CNF CAD Rm Windows desktop w CNF SW
- AWS Conversion Cloud
Large memory or CPU or long running CAD conversion jobs



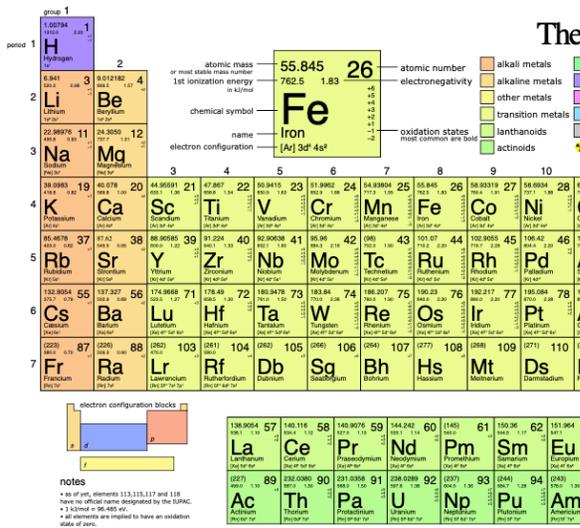
2D Materials Database on MNIC Website



2D Material Properties
Midwest Nano Infrastructure Corridor



Select a Material Group



Includes more than 45 2D materials



Property	WSe ₂	
	Bulk	Monolayer
Lattice constant (a)	3.28 Å [1]	3.32 Å [2]
Molar mass	341.76 g/mol [3, 4]	341.76 g/mol [3, 4]
Band gap type	Indirect [5]	Direct [5]
Band gap energy	1.2 eV (experimental) [6]	1.65 eV (experimental) [5] 1.25 eV (calculation) [2]
Coordination geometry	Trigonal prismatic (W ^{IV}), Pyramidal (Se ⁻²) [3, 4, 7]	Trigonal prismatic (W ^{IV}), Pyramidal (Se ⁻²) [3, 4, 7]
Crystal structure	hP6, space group P6 ₃ /mmc, No 194 [3, 7]	hP6, space group P6 ₃ /mmc, No 194 [3, 7]
Appearance	Grey to black solid [3, 7]	-----
Group	Transition Metal Dichalcogenide [7]	Transition Metal Dichalcogenide [7]
Spin-orbit splitting	-----	0.47 eV [2]
Poisson's ratio	-----	0.19 [2]
Cohesive energy per unit cell	-----	15.45 eV [2]
Charge transfer of W atom	0.96 e [2]	0.96 e [2]
In-plane stiffness	-----	115.52 N/m [2]
Density	9.32 g/cm ³ [3]	9.32 g/cm ³ [3]
Melting point	1500 °C [8]	-----
Exciton binding energy	-----	0.79 eV [9]
W-Se bond length	-----	2.55 Å [2]
Dielectric constant (ε)	-----	Real part (ε ₁)=-22, Imaginary part (ε ₂)=-10 (at 1.7 eV incident photon energy) [10]
Effective masses	-----	m _e = 0.53 m ₀ , m _h = 0.52 m ₀ [11]
Effective Bohr radius	-----	-----
Thermal expansion coefficient	-----	11.08×10 ⁻⁶ /°C [12]
Bulk Modulus (B)	-----	-----
Refractive Index	-----	5.68 [13]
Carrier mobility in WSe₂		
Thicknesses	BN/SiO₂/Si substrate	SiO₂/Si Substrate
8 nm	-----	~350 cm ² /V.Sec (hole) [14]
Monolayer	~31 cm ² /V.Sec [15]	-----
Bulk	-----	-----

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<http://apps.minic.umn.edu/2D/search.php>

Modeling @ GT (Ferroelectrics, Antiferromagnets, Multiferroics, Magnets & their Heterojunctions)

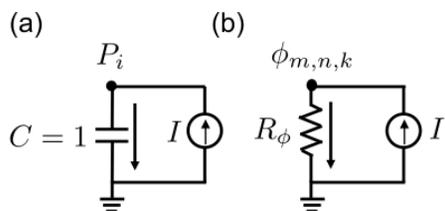
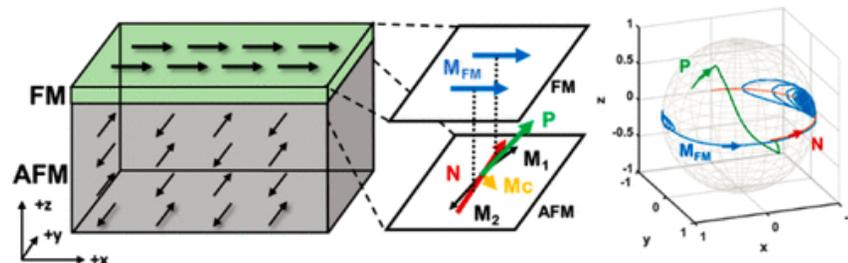
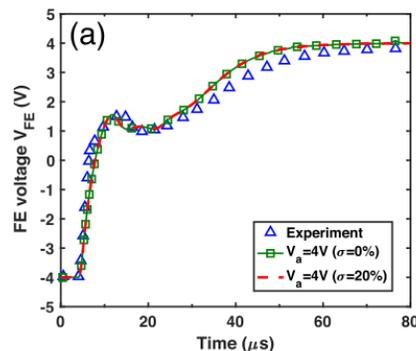


Fig. 1. SPICE equivalent circuit diagrams of (a) TDGL equation, when $i = 1, 2, 3$. (b) Poisson's equation.

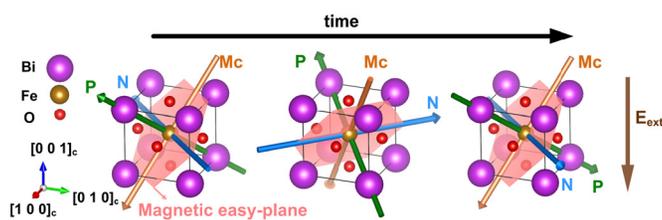


Physics-Based Circuit Models for Phase-Field FE Simulations

IEEE-Trans. Electron Devices, 2020

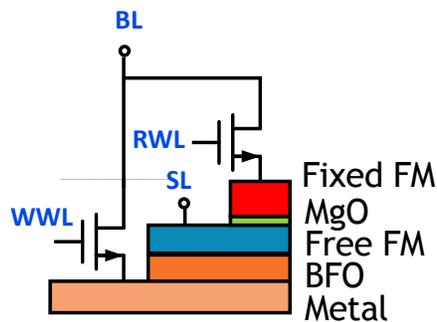
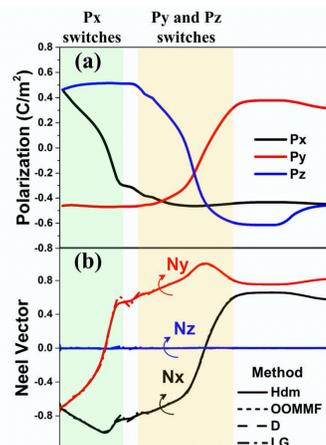
Dynamic Response of BFO/CoFe Heterostructure

To appear in Nano Letters



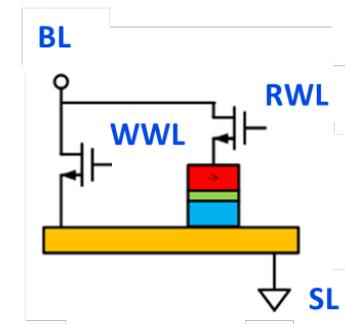
Magnetization Dynamics of a Single-Domain BiFeO3 Nanowire

IEEE-Trans. Magnetism, 2020



Magnetoelectric MRAM

IEEE-JXCDC, 2020



Spin Orbit Torque MRAM

To appear in IEDM 2020

Funded by Intel Co. and SRC

Looking Ahead (Years 6-10)

- The goal is to promote wider use of process and device simulation tools.
- Work closely with Prof. Vasileska (NCI-SW) and Prof. Register (TNF).
- Offer “Device and Process Simulation Course” developed by Prof. Vasileska at the network level.
- Invited e-seminars on various modeling and simulation topics:
 - Simulation approaches for various research areas
 - Emerging modeling and simulation trends
 - Examples of collaborations among theorists and experimentalists
- Promote and help public release of internally developed modeling/simulation tools